

Docket No.: 1592-0163PUS1  
(Patent)

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Patent Application of:  
Masashi NAKAMURA et al.

Application No.: 10/589,733

Confirmation No.: 2225

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Art Unit: 2895

For: VAPOR PHASE GROWTH METHOD

Examiner: A. K. Singal

**REPLY UNDER 37 C.F.R. § 1.116**

**MS AF**  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

**INTRODUCTORY COMMENTS**

In reply to the Office Action dated November 27, 2009, the period for response having been extended one (1) month to March 27, 2010, the following remarks are respectfully submitted in connection with the above-identified application.

**Remarks** begin on page 2.